

FIG. 1C

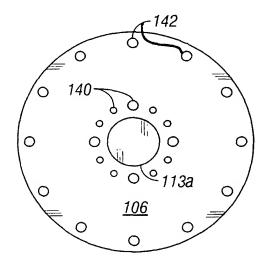


FIG. 1E

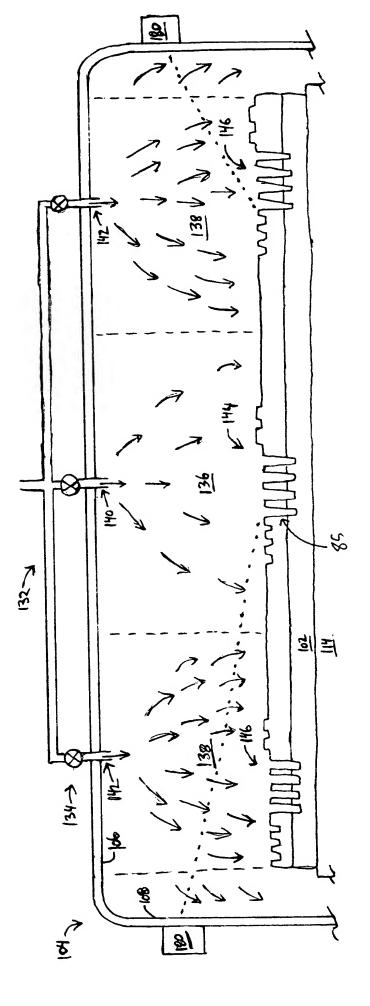


Fig. 1d

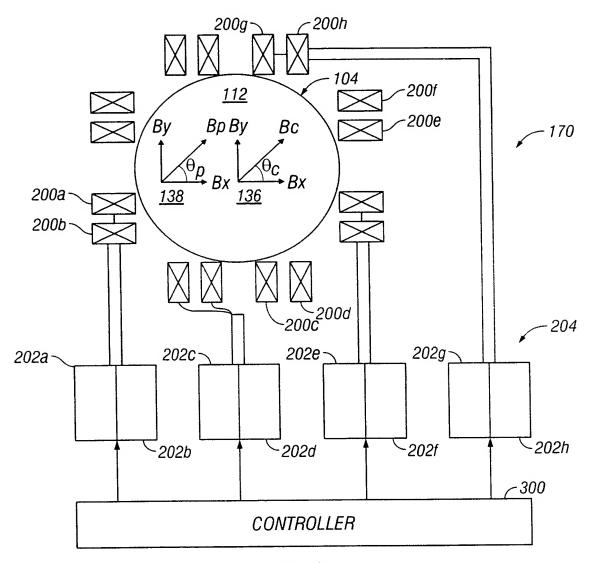
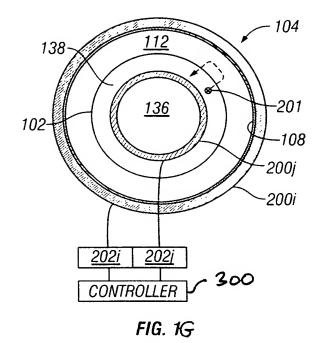
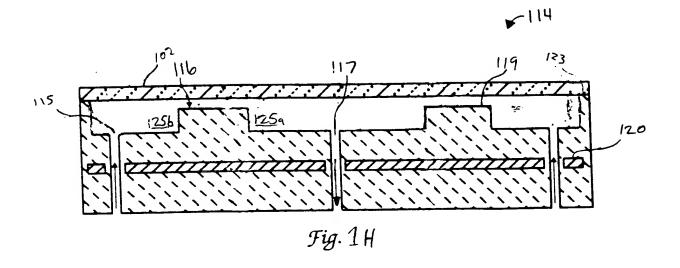
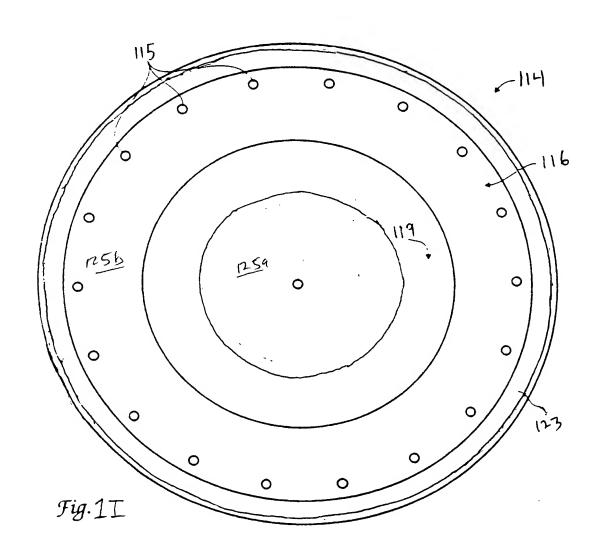


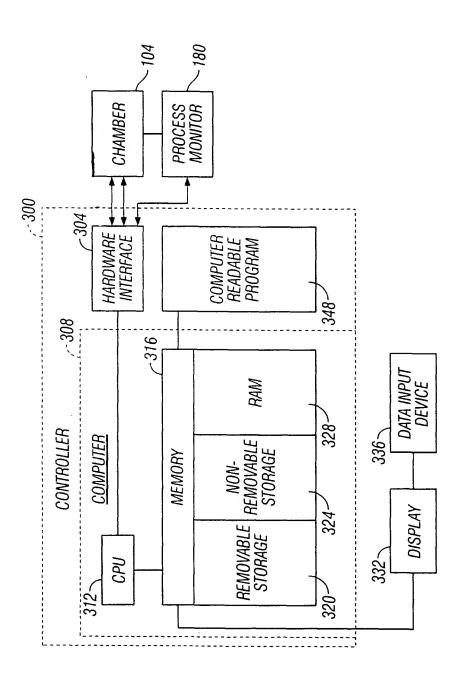
FIG. 1F

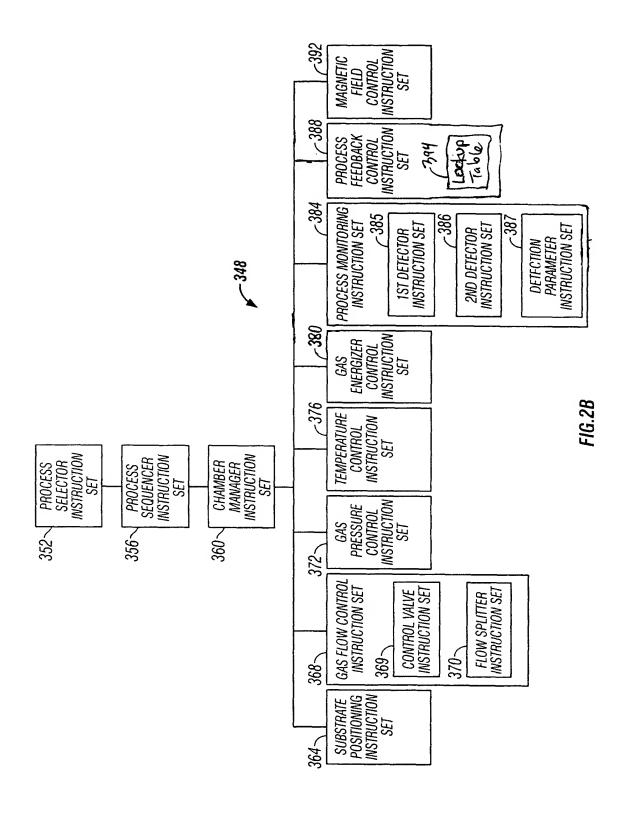


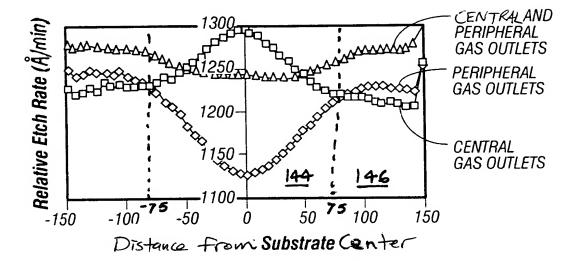












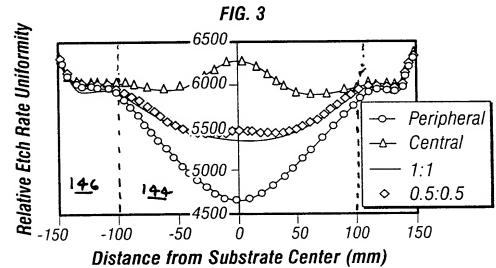
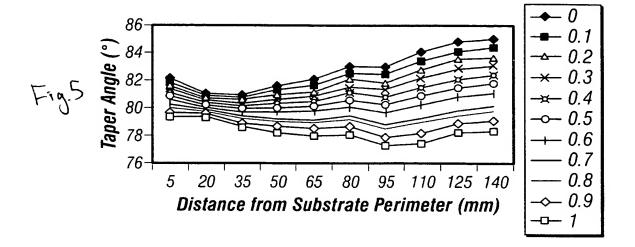
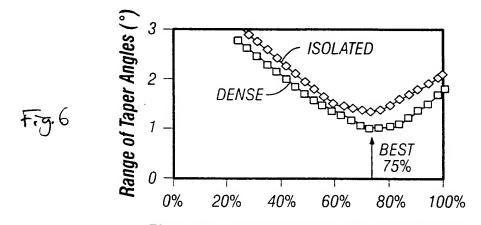
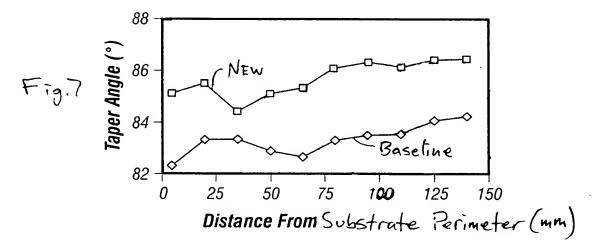


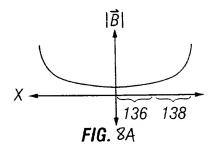
FIG. 4





Flow Through Peripheral Gas Outlets (%)





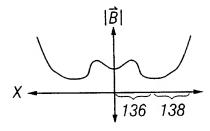


FIG. 88

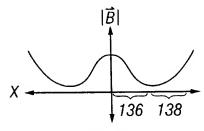
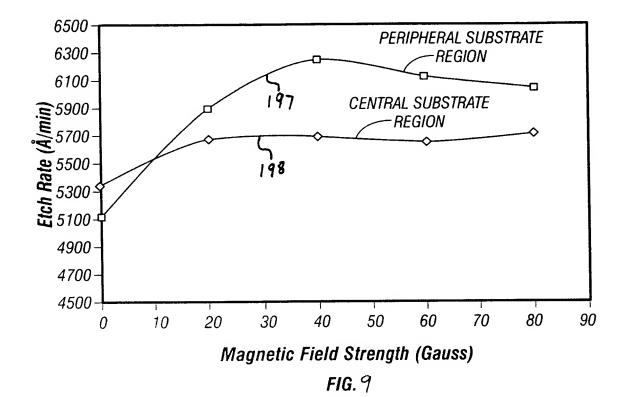


FIG. 8C



6500 SOURCE POWER EFFECTS 6000 800 WATTS Etch Rate (Å/min) SOURCE POWER 5500 550 WATTS SOURCE POWER 4500 -4000 + -100 -50 0 50 100 150 -150

Radial Position on Substrate (mm)

FIG. 10

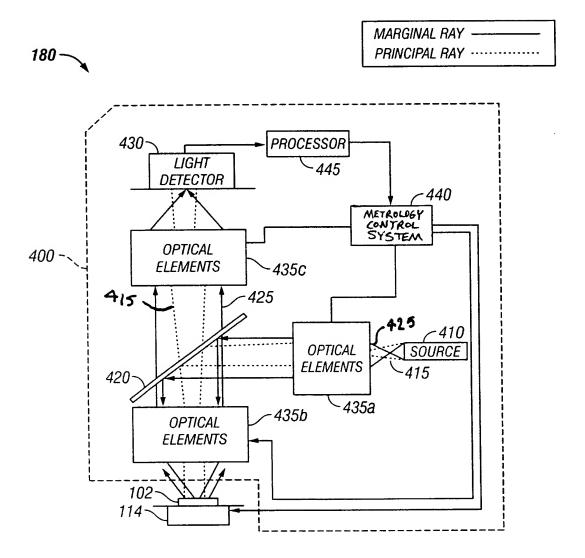


FIG. ||